



JPW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Norikazu OTA et al.

Group Art Unit: 3723

Application No.: 10/790,794

Examiner: L. Wilson

Filed: March 3, 2004

Docket No.: 118858

For: METHOD OF LAPPING MEDIUM-OPPOSING SURFACE IN THIN-FILM  
MAGNETIC HEAD

**AMENDMENT UNDER 37 C.F.R. §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the February 14, 2005 Office Action, and the personal interview conducted on April 12, 2005, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**